Electronic Patent Application Fee Transmittal							
Application Number:	10524525						
Filing Date:	18-Aug-2005						
Title of Invention:	Method for selectively removing material from the surface of a substrate, masking material for a wafer, and wafer with masking material						
First Named Inventor/Applicant Name:	Martin Hausner						
Filer:	David H. Brinkman/Rhonda Etienne						
Attorney Docket Number:	BEET-09						
Filed as Large Entity							
U.S. National Stage under 35 USC 371 Filing Fees							
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Extension-of-Time:							
Extension - 1 month with \$0 paid		1251	1	130	130		

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)			
Miscellaneous:							
Request for continued examination	1801	1	810	810			
	Tot	940					